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*R. Michael A. Baumark*



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Technology Center 2600

**PATENT**

Attorney Docket No. NTI-006

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application )

Inventor(s): Lynn Cai et al. )

Application No.: 09/814,023 )

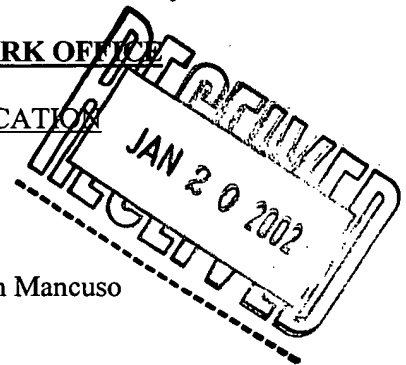
Filed: 03/20/2001 )

Title "SYSTEM AND METHOD OF PROVIDING  
MASK DEFECT PRINTABILITY ANALYSIS" )

PATENT APPLICATION

Art Unit: 2623

Examiner: Joseph Mancuso



**INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §1.97**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

Listed below or on an attached Form PTO-1449 is information known to applicant(s). A copy of each listed publication and U.S. and foreign patent, except for pending U.S. applications, is being submitted herewith, along with a concise explanation of information in a foreign language, if any, pursuant to 37 C.F.R. §1.97-1.98.

Applicants respectfully request that the listed information be considered by the Examiner and be made of record in the above-identified application. If form PTO-1449 is enclosed, the Examiner is requested to initial and return it in accordance with MPEP § 609.

This statement is not intended to represent that a search has been made or that the information cited in the statement is, or is considered to be, material to patentability as defined in 37 C.F.R. § 1.56.